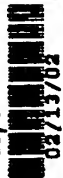


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U.S. UTILITY Patent Application

PATENT NUMBER and
ISSUE DATE

APPL NUM 10075640	FILING DATE 02/13/2002	CLASS 438	SUBCLASS	GAU 2818	EXAMINER D. VU
**APPLICANTS: Nuttall Michael; Mercaldi Gary;					
**CONTINUING DATA VERIFIED: Yes DV THIS APPLICATION IS A DIV OF 09/770,909 01/26/2001					
** FOREIGN APPLICATIONS VERIFIED: None DV					
PG-PUB DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO			
35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		500803.02			
Verified and Acknowledged Examiners's initials DV					
TITLE : Method for enhancing vertical growth during the selective formation of silicon, and structures formed using same					
U.S. DEPT. OF COM. / PAT. & TM-PTO-436L (Rev. 12-94)					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Application Examiner	
		PREPARED FOR ISSUE	
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